

# Optical gain in one-dimensional photonic band gap structures with *n-i-p-i* crystal layers

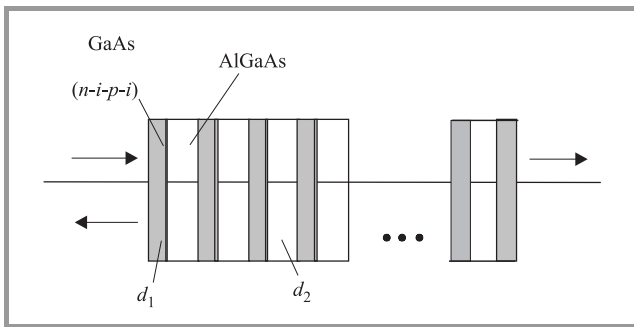
Igor S. Nefedov, Victor N. Gusyatinikov, Marian Marciniak, Valerii K. Kononenko, and Dmitrii V. Ushakov

**Abstract** — The gain enhancement in a layered periodic photonic band gap structure containing active medium based on GaAs *n-i-p-i* superlattices separated by AlGaAs layers is analyzed. The dependences of extinction coefficient and refractive index on excitation level and wavelength are presented. Transmission characteristics of a probe light versus excitation level are calculated. It is shown that the threshold of generation can be essentially reduced if the wavelength of probe light falls to the band gap edge.

**Keywords** — photonic crystal, doping superlattice, optical gain, tunable source.

## 1. Introduction

The interest in multilayer periodic structures forming a photonic band gap (PBG) is increasing because of their attractive application for controllable optical switches and other various nonlinear optical devices [1, 2]. All nonlinear phenomena are enhanced at the PBG edge due to strong delay of the energy velocity and electric field concentration within certain areas of PBG structures. Besides, the optical gain can be enhanced at the band edge in one-dimensional (1D) PBG structures due to the same reasons [3].



**Fig. 1.** 1D PBG structure with the GaAs *n-i-p-i* crystal layers.

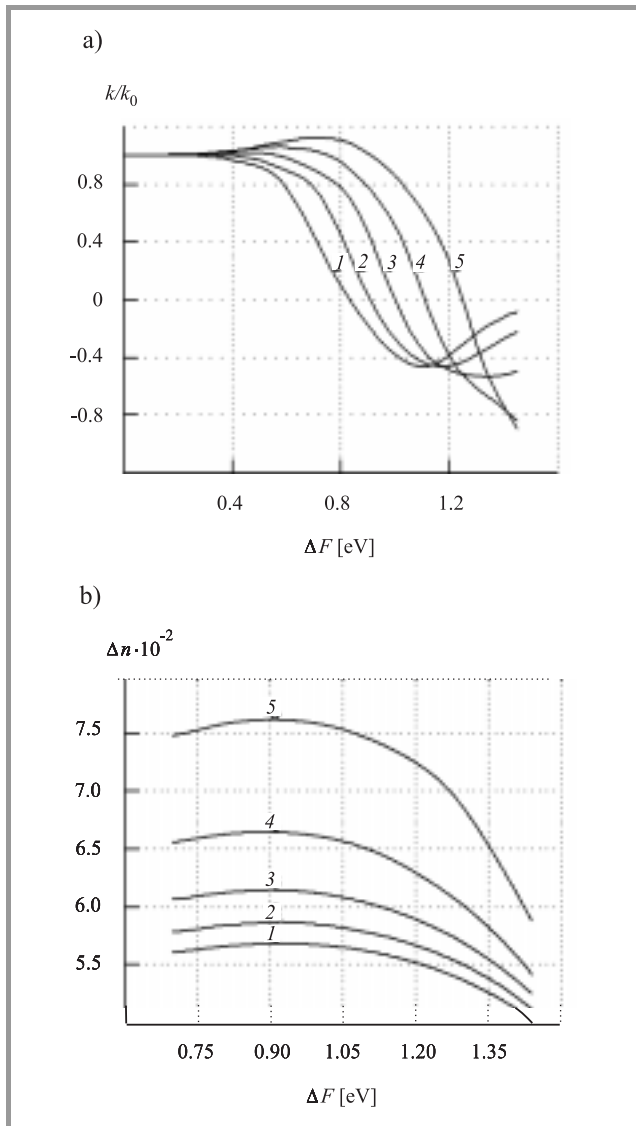
In the present work, the possibilities to use of *n-i-p-i* superlattices as optically controllable active layers in PBG structures are investigated. We consider such a photonic structure in the GaAs-AlGaAs system where the absorption layers with optical controllable parameters are the GaAs *n-i-p-i* crystal layers (see Fig. 1). In certain spectral range the absorption in *n-i-p-i* layers disappears and the light amplification occurs. The gain coefficient in *n-i-p-i* layers depends on the wavelength and the difference in the quasi-

Fermi levels  $\Delta F$ . The model, where a pump, which can be electrical or optical, excites uniformly all active layers, is considered. Light transmission characteristics versus  $\Delta F$ , which is assumed to be the same all over the active layers, are calculated. As shown, the described photonic structures with the *n-i-p-i* layers are attractive to make narrow-band tunable radiation sources.

## 2. Dispersion characteristics of *n-i-p-i* layers

We consider the optical properties of the GaAs-AlGaAs photonic structures where the absorption layers are the GaAs *n-i-p-i* crystal layers (Fig. 1). In particular, the active *n-i-p-i* layers can be in the form of  $\delta$ -doped semiconductor superlattices. In this case, the donor and acceptor concentrations are assumed to be  $N_a = N_d = 10^{20} \text{ cm}^{-3}$ , width of doped *n*- and *p*-type regions  $d_n = d_p = 1 \text{ nm}$ , thickness of *i*-layers  $d_i = 8 \text{ nm}$ . Under optical excitation, the concentration of charge carriers in the *n-i-p-i* layers increases. Therefore, the difference in the quasi-Fermi levels  $\Delta F$  grows and conditions of radiation absorption and refraction change as well.

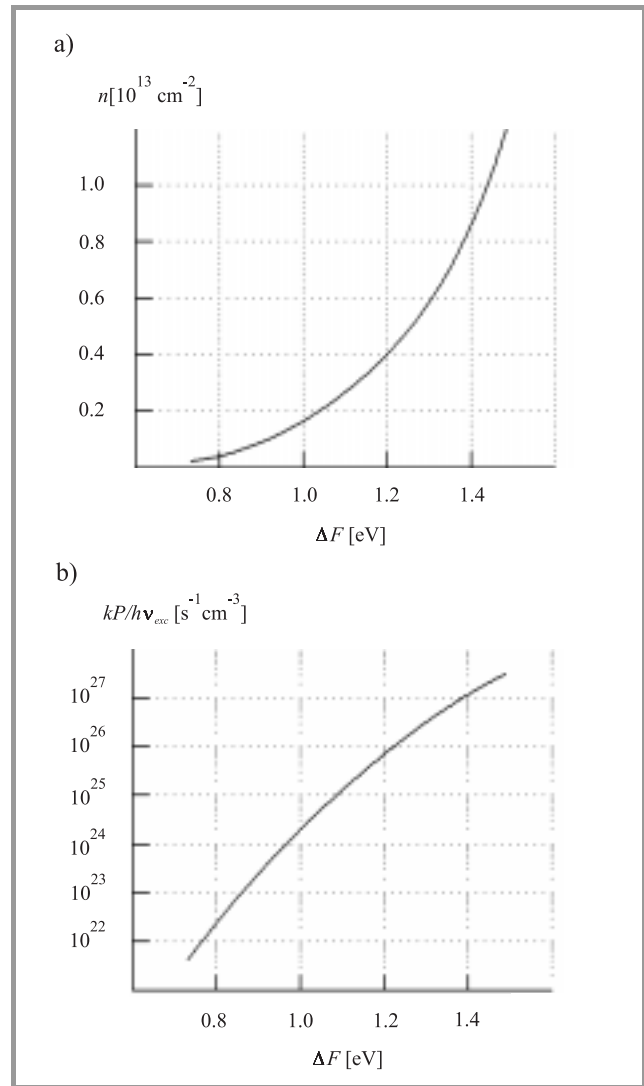
Dispersion characteristics of the *n-i-p-i* layers are shown in Fig. 2. Dependencies of the extinction coefficient  $\kappa$  and change in the refractive index  $\Delta n$  at different wavelengths  $\lambda$  on the excitation level  $\Delta F$  have been calculated according to the Kramers-Krönig relation taking into account the transformation of the potential relief of the doping superlattice under optical or electric excitation. Effects of the density state tails, screening of the impurity electrostatic potential, and shrinkage of the energy band gap are included too [4, 5]. The quantized change in the refractive index  $\Delta n$  is related to the filling of the subband levels by current carriers at the excitation of the layers. At definite values of  $\Delta F$ , the extinction coefficient  $\kappa$  becomes negative, i.e., light amplification occurs in the certain interval of wavelengths. Here, the normalized parameter  $\kappa_0(\lambda)$  is the initial extinction coefficient at the thermodynamic equilibrium ( $\Delta F = 0$ ). The index of refraction of the *n-i-p-i* layers is estimated as a sum of the quantity  $\Delta n$  and the value of the refractive index for the GaAs host material. To find connection between  $\Delta F$  and the exciting radiation power  $P$  in the layers under uniform optical excitation of the structure, the following approach is used. It is assumed



**Fig. 2.** Dependencies (a) of the extinction coefficient  $\kappa$  and (b) quantized refractive index  $\Delta n$  at different wavelengths  $\lambda$  on the excitation level  $\Delta F$ . 1 –  $\kappa_0 = 9.50 \cdot 10^{-6}$ ,  $\lambda = 1500$  nm, 2 –  $\kappa_0 = 3.70 \cdot 10^{-5}$ ,  $\lambda = 1375$  nm, 3 –  $\kappa_0 = 1.68 \cdot 10^{-4}$ ,  $\lambda = 1250$  nm, 4 –  $\kappa_0 = 8.71 \cdot 10^{-4}$ ,  $\lambda = 1125$  nm, 5 –  $\kappa_0 = 4.60 \cdot 10^{-3}$ ,  $\lambda = 1000$  nm.

that the quantum yield at the excitation of the controllable layers in the 1D PBG structure equals 1, i.e., every absorbed quantum produces one electron-hole pair. Concentrations of non-equilibrium carriers are found from the stationary continuity equation that determines the simple relation between the excitation level  $\Delta F$  and the generation rate at the absorption of excitation quantum. The rate of the carrier generation per unit volume in a definite *n-i-p-i* layer is equal to  $kP/h\nu_{\text{exc}}$ , where  $k$  is the absorption coefficient and  $h\nu_{\text{exc}}$  is the energy of excitation quantum. The spectrum of absorption  $k(\lambda)$  is connected with the spectrum of the extinction coefficient as  $k = 4\pi\kappa/\lambda$ .

The increase of the two-dimensional concentration of electrons  $n$  versus the difference in the quasi-Fermi levels  $\Delta F$  is



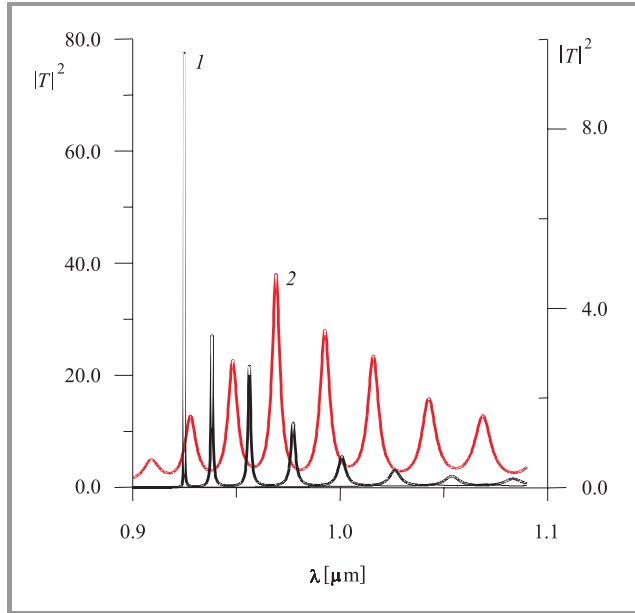
**Fig. 3.** Dependencies (a) of the electron concentration  $n$  and (b) rate of excitation  $kP/h\nu_{\text{exc}}$  on the quasi-Fermi level difference  $\Delta F$  in the *n-i-p-i* layers of the photonic structure.

shown in Fig. 3a. Using the dependence  $n(\Delta F)$ , from the relation between  $kP/h\nu_{\text{exc}}$  and  $\Delta F$ , which is given in Fig. 3b, one can evaluate the effective life-time of carriers at the radiative recombination. For the *n-i-p-i* structure examined, values of the effective life-time of carriers cover a wide range from 1 ms at a low-intensity excitation to 10 ns at the high excitation levels.

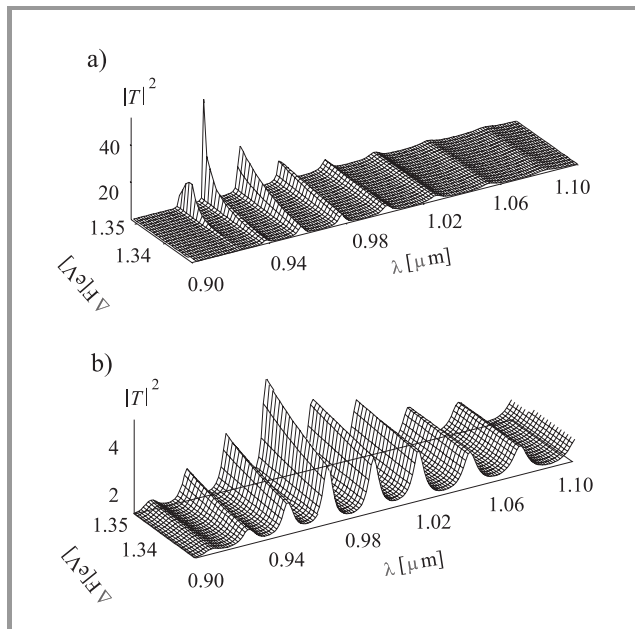
### 3. Gain in the PBG structure

The spectral range where the absorption coefficient in *n-i-p-i* layers is negative at the high excitation levels can be seen in Fig. 2a. The 40-period structure, whose parameters are taken in such a way as the PBG edge falls within the region of maximal gain, was considered. Thicknesses of GaAs and  $\text{Al}_{0.3}\text{Ga}_{0.7}\text{As}$  layers are  $d_1 = 64.5$  nm and  $d_2 = 72.9$  nm, respectively.

The transmission characteristics in a suitable spectral range are presented in Fig. 4, where  $T$  is the amplitude transmission coefficient. The maxima of transmission peaks correspond to the band edges, both of them are within the region of negative absorption coefficients. Thus, the PBG structure with the active  $n-i-p-i$  layers allows considerably to



**Fig. 4.** Transmission coefficient  $|T|^2$  versus the wavelength  $\lambda$  for the 40-period structure (curve 1, left Y-axis) and for the 1-period structure (curve 2, right Y-axis), having the same optical thickness, at  $\Delta F = 1.348$  eV.



**Fig. 5.** Surfaces of the transmission coefficient  $|T|^2$  versus the wavelength  $\lambda$  in microns and difference in the quasi-Fermi levels  $\Delta F$  for (a) the 40-period and (b) 1-period structures of the same optical thickness.

enhance the light amplification and to reduce the necessary level of excitation.

Next two-dimensional surfaces of the transmission  $|T|^2$  versus the difference in the quasi-Fermi levels  $\Delta F$  and the wavelength  $\lambda$  are presented for the 40-period (Fig. 5a) and for the 1-period (Fig. 5b) structures. (One-period structure has the 2582 nm GaAs  $n-i-p-i$  layer and the 2916 nm  $\text{Al}_{0.3}\text{Ga}_{0.7}\text{As}$  layer). One can see that the gain is achieved for the 40-period structure exceeds in an order the gain in 1-period structure having the same optical length of active medium. If the excitation level  $\Delta F = 1.348$  eV, that corresponds to the peak of transmission  $|T|^2 = 5$  for the 1-period structure (Fig. 4), we obtain  $|T|^2 \approx 80$  for the 40-period structure at the wavelengths corresponding to the band edges. The gain starts to rise markedly from some a threshold level of excitation. This threshold level for the 1-period structure significantly exceeds the respective values for the 40-period structure.

## 4. Discussion

Thus, the results obtained show that 1D PBG structure with the active  $n-i-p-i$  layers can be promising for creating miniaturized light sources. The main advantage of the resonator with active medium embedded into periodic multilayer is caused by strong delay of the energy velocity in comparison with the energy velocity in a bulk material or in DFB structure with a slight index modulation [6]. Comparison with one-period structure shows that application of the multiperiod structure allows to reduce the resonator length where threshold of generation can be achieved at the same parameters of active medium and the excitation level. Thus, a laser used the resonator considered can be alternative to the DFB laser whose fabrication is too complicated, quite expensive and low-reproducible.

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## References

- [1] M. Scalora, J. P. Dowling, C. M. Bowden, and M. J. Bloemer, "Optical limiting and switching of ultrashort pulses in nonlinear photonic band gap materials", *Phys. Rev. Lett.*, vol. 73, pp. 1368–1371, 1994.
- [2] I. S. Nefedov and V. N. Gusyatinikov, "Optically controlled GaAs-GaAlAs photonic band gap structure", *J. Opt. A*, no. 2, pp. 344–347, 2000.
- [3] J. P. Dowling, M. Scalora, M. J. Bloemer, and C. M. Bowden, "The photonic band edge laser: a new approach to gain enhancement", *J. Appl. Phys.*, vol. 75, pp. 1896–1994, 1994.
- [4] V. K. Kononenko, I. S. Manak, and D. V. Ushakov, "Optoelectronic properties and characteristics of doping superlattices", *Proc. SPIE*, vol. 3580, pp. 10–27, 1998.
- [5] V. K. Kononenko and D. V. Ushakov, "Carrier transport and screening in  $n-i-p-i$  crystals", *Phys. Stat. Sol. (B)*, vol. 211, pp. 743–749, 1999.

- [6] J. E. A. Whiteaway, B. Garrett, G. H. B. Thompson, A. J. Collar, C. J. Admstead, and M. J. Fice, "The static and dynamic characteristics of single and multiple phase-shifted DFB laser structures", *IEEE J. Quant. Electron.*, vol. 28, pp. 1277–1293, 1992.



**Igor S. Nefedov** graduated from Saratov State University, Saratov, Russia in 1972 and received the M.Sc. degree in radio physics and electronics. He received the Ph.D. and Doctor of Science (habilitation) degrees in radio physics in 1981 and 1998, respectively. From 1981 to 1992 he was a researcher at the Research Institute of Mechanics

and Physics, Saratov State University. From 1992 he is a Leading Researcher at the Institute of Radio Engineering and Electronics of Russian Academy of Sciences, Saratov, Russia. In 2001–2002 I. Nefedov is a Visiting Professor of Radiolaboratory at Helsinki University of Technology. His research interests are in area of electrodynamics of anisotropic and gyrotropic media and photonic band gap structures as well as optical switching. He has published about 100 scientific papers.

Institute of Radioengineering and Electronics, RAS  
Saratov Department  
Zelyonaya st 38  
410019 Saratov, Russia



**Victor N. Gusyatnikov** graduated from Saratov State University, Saratov, Russia, in 1977 and received the M.Sc. degree in semiconductor physics. He received the Ph.D. degree in semiconductor physics from the Nizhni Novgorod State University, Nizhni Novgorod, Russia. From 1993 to 1998 he was a manager of laboratory of

physics of semiconductors at the Research Institute of Mechanics and Physics, Saratov State University. Now, he is a senior lecturer at the Saratov State Social and Economic University. His research interests are electronic processes in semiconductor structures in strong electrical and electromagnetic fields, optical, photoelectric, kinetic properties of classical semiconductor superlattices, theory of photonic band gap structures, computing and scientific programming. He has published more than 50 papers. Dr. Gusyatnikov is a Soros Associate Professor (2001).

Institute of Radioengineering and Electronics, RAS  
Saratov Department  
Zelyonaya st 38  
410019 Saratov, Russia



**Marian Marciniak** Associate Professor has been graduated in physics from Marie-Curie Sklodowska University in Lublin, Poland, in 1977. From 1985 to 1989 he performed Ph.D. studies in electromagnetic wave theory at the Institute of Fundamental Technological Research, Polish Academy of Sciences, followed by Ph.D. degree (with

distinction) in optoelectronics received from Military University of Technology in Warsaw. In 1997 he received his Doctor of Science (habilitation) degree in optics from Warsaw University of Technology. From 1978 to 1997 he held an academic position in the Military Academy of Telecommunications in Zegrze, Poland. In 1996 he joined the National Institute of Telecommunications in Warsaw where he actually leads the Department of Transmission and Fibre Technology. His research interests include photonics, terabit networks, IP over WDM networks, optical waveguide theory and numerical modelling, beam-propagation methods, and nonlinear optical phenomena. He is an author or co-author of over 160 scientific publications in those fields, including three books. He is an active member of the IEEE – Lasers & Electro-Optic Society, IEEE – Communications Society, New York Academy of Sciences, Optical Society of America, SPIE – The International Society for Optical Engineering and its Technical Group on Optical Networks, and American Association for the Advancement of Science. He was the originator of accession of Poland to European Research Programs in the optical telecommunications domain: COST 240 *Modelling and Measuring of Advanced Photonic Telecommunication Components*, COST 266 *Advanced Infrastructure for Photonic Networks*, COST 268 *Wavelength-Scale Photonic Components for Telecommunications*, and COST P2 *Applications of Nonlinear Optical Phenomena*. He has been appointed to Management Committees of all those Projects as the Delegate of Poland. He has been appointed as the Evaluator of the European Union's 5th Framework Program proposals in the Action Line *All-Optical and Terabit Networks*. He is a Delegate to the International Telecommunication Union, Study Group 15: *Optical and Other Transport Networks*, and to the International Electrotechnical Commission, Technical Committee 86 *Fibre Optics* and its sub-Committees. He served as a Delegate to the *World Telecommunication Standards Assembly WTSA 2000*. He is the originator and the Chairman of the Topical Commission on *Fibre Technology* of the National Committee for Standardisation. In early 2001 he originated the IEEE/LEOS Poland Chapter and actually he serves as the Interim Chairman of that Chapter. He participates in Program Committees of several international conferences, and he is a reviewer for several international scientific journals. In addition to that, he serves as a Member of the Editorial Board of *Microwave & Optoelectronics Technology Letters* journal, Wiley, USA,

and the *Journal of Telecommunications and Information Technology*, National Institute of Telecommunications, Poland. He was the originator and the organiser of the 1st, 2nd and 3rd *International Conferences on Transparent Optical Networks ICTON'99*, 2000, and 2001. Recently he has been appointed by the *World Scientific and Engineering Society* to act as the originator and Chairman of the *WSES International Conference on Wireless and Optical Communications 2002*. His biography has been cited in *Marquis Who's Who in the World*, *Who's Who in Science and Engineering*, and in the *International Directory of Distinguished Leadership of the American Biographical Institute*.

e-mail: M.Marciniak@itl.waw.pl

National Institute of Telecommunications

Szachowa st 1

04-894 Warsaw, Poland



**Valerii K. Kononenko** graduated in radiophysics from the Byelorussian State University, Minsk, BSSR, in 1965. He received the Ph.D. degree in quantum electronics from the Institute of Physics, Academy of Sciences of the BSSR, in 1972, the D.Sc. degree in physics of semiconductors and dielectrics in 1992, and the

academic status of Professor in physics in 1997. In 1965 he joined Stepanov Institute of Physics, National Academy

of Sciences of Belarus, where he currently heads the Scientific Group at the Laboratory of Optics of Semiconductors. His present research interests concern nonlinear optical properties of low-dimensional systems including quantum-well lasers and wide-band gap semiconductor superlattices. He is the author of three books, holds five technical patents, and has published more than 110 journals articles and a number of reviews. Dr. Kononenko is a member of the SPIE, International Technical Working Groups on Optical Materials, Belarussian and European Physical Societies, and Polish Society of Sensor Engineering.

e-mail: lavik@dragon.bas-net.by

Stepanov Institute of Physics, NASB

220072 Minsk, Belarus



**Dmitrii V. Ushakov** received the M.Sc. and Ph.D. degrees in Radiophysics and Electronics Department of Belarussian State University, Minsk, Belarus. His research interests and experience include physics of semiconductor doping superlattices, hetero-*n-i-p-i* structures, quantum cascade lasers, and photonic band gap crystals. He

has published more than 20 papers.

Stepanov Institute of Physics, NASB

220072 Minsk, Belarus